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PATENT
450104-03688

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : ESASHI Masayoshi, et al
Int'l Appln. No. : PCT/JP00/02739
Int'l Filing Date : April 27, 2000
Title of Invention : METHOD OF MANUFACTURING A
MICROMACHINE

745 Fifth Avenue
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Date of Deposit: October 25, 2001

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Enclosed are copies of the publications, which were cited in the International Search Report of International Application No. PCT/JP00/02739. Also enclosed is a copy of Form PTO-1449 and the International Search Report.

PATENT

450104-03688

25 OCT 1975

REMARKS

Entry of this Information Disclosure Statement and an early examination on the
merits are respectfully solicited.

Please charge any additional fees to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMERM LAWRENCE & HAUG LLP

By:



William S. Frommer

Reg. No. 25.506

(212) 588-0800

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Enclosures

10/01/00

3 Rev 6 7/27/00 25 OCT 2001

Sheet 1 of 1

Based on Form PTO-1449 (3-90)			ATTY DOCKET NO 450104-03688	SERIAL NO			
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)			APPLICANT ESASHI Masayoshi, et al				
			FILED DATE Filed Concurrently	GROUP			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
	AA	5,955,776	09 21 99	Ishikaa			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES
	AK	9-288124	11 04 97	Japan			
	AL	10-96741	04 14 98	Japan			
	AM	10-154820	06 09 98	Japan			
	AN	10-313139	11 24 98	Japan			
	AO	6-335265	12 02 94	Japan			
	AP	98 25090	06 11 98	WIPO			
	AQ	1239543	12 22 99	China			
	AR	360909	06 11 99	Taiwan			
	AS						
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AI		Norio Takeda et. al., "Ball Semiconductor Gijutsu to MEMS sensor e no Oyo", IEEJ Kenkyukai Shiryou, SMP 99-5-9, 23 July 1999, pp. 1-6				
	AU		Masaki Yamashita et. al., "Kyumen Handoutai no Kangae Kata to Sono Kaihatsu Jokyo", Densi Zairyo, vol. 37, no. 11, 1998, pp. 21-26				
EXAMINER				DATE CONSIDERED			
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